



JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 7179**
Takayuki SAITO et al. : Attorney Docket No. 2003_1585A
Serial No. 10/695,826 : Group Art Unit 1746
Filed October 30, 2003 : Examiner Alexander Markoff

SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

RESPONSE TO RESTRICTION REQUIREMENT (INVENTION)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of September 29, 2006, Applicants hereby elect the invention of Group I, claims 1-8, drawn to an apparatus, without traverse, for further prosecution. In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Takayuki SAITO et al.

By: 

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October 17, 2006

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